







DEPARTMENT OF ELECTRICAL AND ELECTRONICS ENGINEERING & INTERDISCIPLINARY NANO RESEARCH CENTRE



PRESENTS

EXCLUSIVELY

FOR RESEARCH SCHOLARS AND SVCE FACULTIES

WORKSHOP ON

IC FABRICATION



RESOURCE PERSON

Peter Lee, Manager, Midas System Co Ltd Republic of Korea

CHIEF PATRON

Prof. M. Sivanandham, Secretary, SVCE

PATRON

Prof. S. Ganesh Vaidyanathan, Principal, SVCE

CONVENOR

Dr.KR.Santha, Vice-Principal, Professor & Head of Dept, Department of EEE





Dr.Sudhakar.KB,Prof/EEE

NO REGISTRATION FEE

LIMITED SEATS ONLY

7TH - **9**TH

NOV



For Queries Contact: 9629713099

Sri Venkateswara College of Engineering Pennalur, Sriperumbudur 602117

Interdisciplinary Nano Research Centre

Three days workshop on IC Fabrication: November 7th -9th, 2021

Workshop Report

Department of Science and Technology (DST) FIST sponsored Interdisciplinary Nano Research Centre (iNRC), Sri Venkateswara College of Engineering, houses a1000 Sq.ft non-conventional Class-10,000 clean-room facility with state-of-the-art sophisticated nano-fabrication and characterization facilities, which provides end to end support from IC design, Nano-device modeling, fabrication and characterization.

A new state-of-the-art MDA-400LJ Mask Aligner and exposure system was procured from Midas System Co. Ltd, South Korea. Mr.Peter Lee, Manager, Midas Systems, and Mr.Rahul Chaudhary, Director, Aura Innovative Technologies, New Delhi, visited SVCE from 06th to 09th of November 2021 and trained a team of faculty members at SVCE headed by Dr.Sudhakar.KB, Prof/EEE on IC Fabrication and the process of Photolithography. The laboratory which specializes on thin film technology has now developed into a fully functional Nano device fabrication facility, with the installation of Photolithography- Mask Aligner and Exposure System. This facilitates SVCE to design and fabricate a complete IC chip and various other optoelectronic devices.

Fields of Application: Micro- and Nano-electronics, MEMS, Nanobiotechnology, Biomedical devices, Wearable devices, Smart Materials, Solar and sustainable energy.

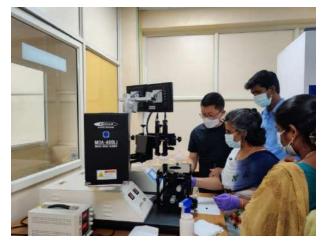
Summary of Events:

Nov 6 th 2021	Start of installation: Opening of the Mask aligner System and checking all	
	the components and modules.	
Nov 7 th 2021	1. <u>Hands-on demonstration</u> of the mask aligner and exposure system.	
	2. Photolithography process – Patterning, Etching and Developing.	
	3. Alignment process – Multi step lithography with alignment.	
Nov 8 th 2021	Hands-on training of the above process by the SVCE faculty members.	
Nov 9 th 2021	<u>Interactive session</u> - Experts and participants.	

K3 BLE Workshop Coordinator

KR. Sanl

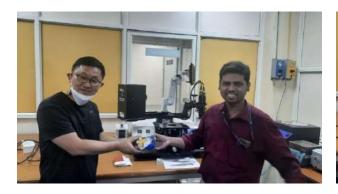
Event pictures:













K3.ld.k. Workshop Coordinator

KR. Sant

Participants List:

S.No	Title	Name	Designation	Department
1	Ms	ANITHA S	Assistant Professor	EEE
2	Mrs	SASIKALA M	Assistant Professor	EEE
3	Mrs	SINTHAMANI S	Assistant Professor	EEE
4	Mr	S.SUDHARSANAM	Assistant Professor	EEE
5	Mrs	M.RANJITHKUMAR	Assistant Professor	EEE
6	Mr	VINOTH KUMAR G	Assistant Professor	EEE





The Department of **Electrical and Electronics**

Engineering







Sri Venkateswara College of **Engineering**



COLLEGE

Autonomous - Affiliated to Anna University Pennalur, Sriperumbudur, Tamil Nadu I www.svce.ac.in

Department of Electrical and Electronics Engineering INTERDISCIPLINARY NANO RESEARCH CENTRE

Certificate of Participation

This is to certify that

S. Anitha

SRI VENKATESWARA COLLEGE OF ENGINEERING

has participated in the International workshop on IC FABRICATION organized by the Department of Electrical and Electronics Engineering in association with Midas systems, Korea on 7th - 9th July 2021.

K.B. LShly

Dr. Sudhakar K Bharatan Prof/EEE

Event Coordinator

kr. Sanl

Dr. K R. Santha Vice Principal, Prof & Head / EEE









Performer







Certified Organization





Accreditations

Top Ranked Affiliated Institution in Tamil Nadu

